

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Not for submission under 37 CFR 1.99)

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| Application Number | 09/373,585 |
| Confirmation Number | 2737 |
| Filing Date | August 13, 1999 |
| First Named Inventor | Nobuhiko OGURA |
| Art Unit | 1634 |
| Examiner Name | Frank Wei Min LU |
| Attorney Docket Number | Q55432 |

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| Examiner Initials* | Cite No | Patent Number | Kind Code ¹ | Issue Date | Name of Patentee or Applicant of cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
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NON-PATENT LITERATURE DOCUMENTS

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EXAMINER SIGNATURE

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| Examiner Signature | /Frank Lu/ | Date Considered | 08/20/2008 |
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